Application/Control No. 09/772,779 Cited Applicant(s)/Patent Under Reexamination CHEN ET AL. Examiner Betsy L. Deppe 2634 Page 1 of 1

Notice of References Cited

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	А	US-5,754,583	05-1998	Eberhardt et al.	375/147
-	γВ	US-6,097,972	08-2000	Saints et al.	455/572
	С	US-6,208,699 B1	03-2001	Chen et al.	375/340
	D	US-6,621,808 B1	09-2003	Sadri, Ali S.	370/335
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	,	US-			
	J	US-			
	к	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0	- - "				
	Р					
	Q					
	R					
	S					
	т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	v							
	w							
	х							

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

U.S. Patent and Trademark Office PTO-892 (Rev. 01-2001)